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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**NAME OF THE APPLICATION OF:**

Masaaki TAKATA, et al.

GROUP: 3749

SERIAL NO: 10/809,705

FILED: March 26, 2004

EXAMINER:

FOR: THERMAL TREATMENT SYSTEM FOR SEMICONDUCTORS

**SUBMISSION OF SUPPLEMENTAL APPLICATION DATA SHEET**

Office of Initial Patent Examination  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit herewith a Supplemental Application Data Sheet for the above-identified application for the purpose of correcting the Assignment for Published Patent Application information.

Respectfully Submitted,

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